



IFW

80236DPCW
Customer No. 01333

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ramanathan Srinivasan, et al

**SLURRY FOR CHEMICAL
MECHANICAL POLISHING
SILICON DIOXIDE**

Serial No. 10/617,510

Filed 11 July 2003

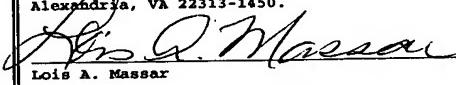
Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

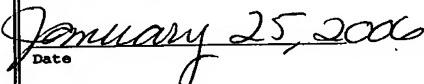
Sir:

Group Art Unit: 1751

Examiner: Webb, Gregory E.

I hereby certify that this correspondence is being deposited today with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Lois A. Massar


Date

Response
The following is in response to the office action mailed January 4, 2006.

Remarks/Arguments begin on page 2 of this paper.